

Data Sheet- EddyCus® TF map 2530SR-A

P_T_2530_11



Highlights

- ▶ Contact-free imaging
- ▶ High resolution imaging (25 to 1,000,000 points)
- ▶ Integrity and defect imaging
- ▶ Mapping of encapsulated layers

Processes

- ▶ Deposition (PVD, evaporation, plating, CVD, ALD ...)
- ▶ Layer and material modification (implantation, doping, annealing)
- ▶ Layer removal (CMP, etching, scribing ...)

Applications

- ▶ Semiconductors
- ▶ Photovoltaics
- ▶ Touch panel sensors
- ▶ Displays and lighting
- ▶ Batteries, capacitors, fuel cells
- ▶ De-icing and heating
- ▶ Smart-glass and LowE
- ▶ WLP, PCB
- ▶ Packaging materials
- ▶ Antistatic

Materials

- ▶ Semiconductors (Si, SiC, GaAs ...)
- ▶ Metals
- ▶ Graphene, CNT, graphite
- ▶ Conductive oxides and nitrides
- ▶ Mesh and nanowire films
- ▶ Conductive inks, polymers (PEDOT)
- ▶ Other conductive films

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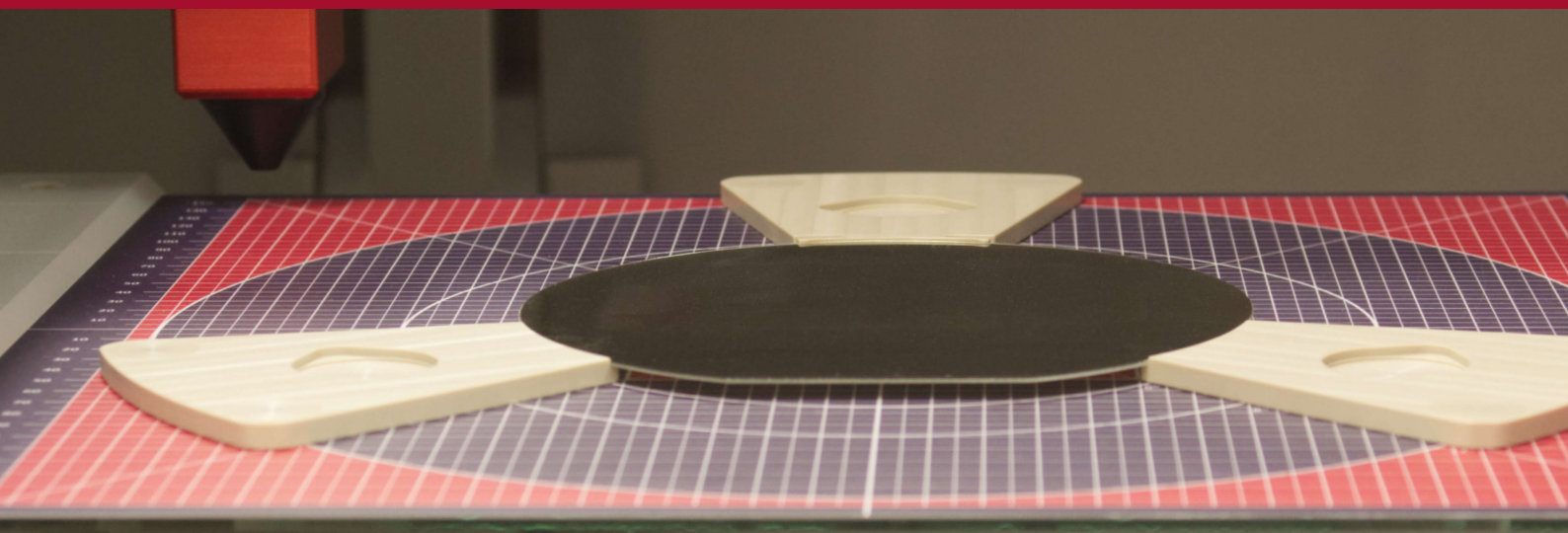
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Made and Engineered in Germany

Innovation Award by
Free State of Saxony 2013
1st Place





Measurement technology	Non-contact eddy current sensor
Substrates	Foils, glass etc. ≥ 100 mm x 100 mm
Max. scanning area	12 inch / 300 mm x 300 mm (larger on request)
Edge effect correction / exclusion	2 – 10 mm (depending on size, measurement range and requirements)
Max. sample thickness / sensor gap	2 / 5 / 10 / 25 mm (defined by the thickest sample / application)
Sheet resistance range	0.001 – 10 Ohm/sq; 2 to 7 % accuracy
accuracy can be optimized over sheet resistance decade within a customer specified range	0.01 – 1,000 Ohm/sq; 2 to 7 % accuracy 10 – 3,000 Ohm/sq; 2 to 7 % accuracy
Anisotropy range	0.33 – 3 (0.1 – 10 on request)
Thickness measurement of metal films (e.g. copper)	2 nm – 2 mm (in accordance with sheet resistance)
Scanning pitch	1 / 2.5 / 5 / 10 / 25 mm (other on request)
Measurement points per time (quadratic shape)	10,000 measurement points in 5 minutes 1,000,000 measurement points in 30 minutes
Scanning time	8 inch / 200 mm x 200 mm in 1.5 to 15 minutes (1 – 10 mm pitch) 12 inch / 300 mm x 300 mm in 2 to 15 minutes (2.5 – 25 mm pitch)
Device dimension (w / h / d) / weight	31.5 x 19.1 x 33.5 inch / 799 x 486 x 850 mm / 90 kg

Software and Handling - Sheet Resistance Analyzer 2.0

